

# <u>Isothermal VA</u>cuum <u>Chromatography</u> (IVAC) @TASCA

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## Why Vacuum?



#### dimer formation (non metals) $\leftarrow \rightarrow$ lattice formation (metals)



# Why Vacuum?

#### Eichler-Miedema $\Delta H_{ads}$ (A in surface of B), kJ/mol





- \* Fast chromatographic process
- \* Clean surfaces
- \* Stable surfaces also for more reactive metals
- \* Stable elemental state for TA
- \* No co-adsorption phenomena
- \* (Good spectroscopic resolution)





#### **Heavy Ion induced Nuclear Fusion Reaction**

#### **Recoiling Products with momentum of the beam: ->~30-50 MeV**

**Thermalization ???** 

#### Catcher Materials (Diffusion/Release)

or

**Gas jet** (Impaction → Desorption)

Vacuum Chromatography



#### **Impaction and Release**

#### **Release Kinetics**



#### J. Askill, Tracer Diffusion, Plen. Press, IFI 1970



## **CRATE @ BGS**





# **CRATE @ BGS**





## **IVAC Schematic**





## **IVAC Schematic**





# **IVAC Set-Up**

#### Angular distribution of products leaving the column





# **CRATE @ BGS**





### **CRATE @ BGS**





#### **Impaction and Release**

Mylar degraders / Implantation depth





#### **Metal-Aerosol Particles**





## **Metal-Aerosol Particles**

<sup>nat</sup>Sm(<sup>40</sup>Ar,6n)<sup>178-185</sup>Hg(α) –

→ PSI TAPE Detection system



11 He+100 ml/minAr

12 h experiments R.Elchler, TASCA Workshop Davos Sept. 28, 2007





#### column length: 30 cm





# **IVAC Set-Up**

#### column length: 30 cm column length (Pb) 10 cm





### **Experiments with Detectors**



Problem: semiconductors detectors are sensitive to light irradiation (visible light, IR)
Solution: coverage of detector surface by protection layer (carbon, metals with low Z)

Coverage materials used: C, Al, Mg, Mn, Co, Fe, Zn, Ag

**Best material** 



#### **Experiments with Glasses**



#### Covered and non-covered glass 60 µg/cm<sup>2</sup> Mg/MgO Coverage



## **Experiments with PIN/PIPS Detectors**



α-source: <sup>227</sup>Ac (located at sealed end of column, inside of the oven)

<sup>227</sup>Ac  $\rightarrow$  <sup>219</sup>Rn (E<sub> $\alpha$ </sub>=6,8MeV)  $\rightarrow$  <sup>215</sup>Po (E<sub> $\alpha$ </sub>=7,6MeV)  $\rightarrow$  <sup>211</sup>Pb( $\beta$ )  $\rightarrow$  <sup>211</sup>Bi (E<sub> $\alpha$ </sub>=6,6MeV)

Column length: 15 cm Outlet of oven shielded by aluminum foil Diode located at ~5mm from the open end of column



# **Experiments with PIN/PIPS Detectors**

#### Online Tests with $\alpha$ -source



**Maximal operation temperature for:** 

- 1) Non-covered  $375 \ ^{\circ}C$
- 2) Covered  $675 \, {}^{0}C (!)$

#### $\alpha$ -resolution needed is about <100 keV



# **R&D Proposal IVAC@TASCA**

- Test experiment: 2x 6 Shifts <sup>40</sup>Ar, <sup>nat</sup>Sm, <sup>nat</sup>Gd targets from GSI, Metal Aerosol tests with Pb and Hg GSI – ROMA Detection system (Fall 2008) (PSI-RTC, Small Image Mode)
   Test experiment: 2x 6 shifts <sup>40</sup>Ar, <sup>nat</sup>Sm, <sup>nat</sup>Gd targets from GSI, Gas-jet Impaction and Release Experiments with CRATE&IVAC (2009) (PSI-RTC, Small Image Mode)
- 3. Test experiment: 2x6 Shifts <sup>40</sup>Ar, <sup>nat</sup>Sm, <sup>nat</sup>Gd targets from GSI, CRATE with Catcher & IVAC (Silicon, Sn(?) TUM) (2009)

4. Follow-on Proposal: Hg, Tl, Pb, Bi, Po, At studies on various

stationary phases (Cu, Ag, Au, SiO<sub>2</sub>)(2010).

5. Experiments with TA not before 2011-2012